ELSEVIER

Thin Solid Films 358 (2000) 303–304

thin solid films

Author Index of Volume 358

Adams, P.M., 131
Addou, M., 40
Agarwal, V., 196
Al-Shukri, A.M., 166
Alvisi, M., 250
Anderson, O., 202
Anopchenko, A., 90
Aschentrup, A., 90
Atteridge, D., 146

Badrinarayanan, S., 122
Bange, K., 202
Barber, Z.H., 264
Becker, M., 146
Belenchuk, A., 277
Benseddik, E., 40
Bente, K., 80
Bernéde, J.C., 40
Boughaba, S., 104

Castro-Rodríguez, R., 12
Chan, Y.C., 16
Chaparro, A.M., 22
Chen, M.-C., 180
Cheng, S.C.N., 215
Chia, C.T., 139
Chiu, K.-F., 264
Choi, H.M., 202
Choi, S.K., 202
Choi, S.-S., 223
Chuang, A., 292
Chung, H.J., 86
Churms, C.L., 270
Cohen Stuart, M.A., 234
Collins, S.J., 229
Comrie, C.M., 270
Cremona, M., 191

Despax, B., 30
Dhathathreyan, A., 229
Di Giulio, M., 250
Durrani, S.M.A., 166

El Idrissi, E., 40

Fedorov, A., 277
Fleer, G.J., 234
Fornarini, L., 191

Gerber, R., 206
Grünleitner, H., 73
Graham, M.J., 104
Grier, E.J., 94
Gu, Y.W., 139
Gutiérrez, M.T., 22

Hahn, T.-S., 223
Haindl, G., 90
Hallil, A., 30
Hamelmann, F., 90
Heczko, O., 206
Heifets, E., 1
Heinzmann, U., 90
Herrero, J., 22
Hiesgen, R., 241
Hong, K.-S., 223
Huang, F.-S., 292
Huhtinen, H., 277
Hundhausen, M., 73
Hwang, J., 292

Islam, M., 104

Jenkins, M.L., 94
Jergel, M., 90
Jiménez, J., 56
Jimenez-Sandoval, S., 12
Jutzi, P., 90

Kachouane, A., 40
Kam, C.H., 16
Kantser, V., 277
Kasperczyk, J., 114
Kawamoto, Y., 99
Khawaja, E.E., 166
Khor, K.A., 139
Kim, C.-H., 223
Kim, E.K., 259
Kim, I.-T., 223
Kityk, I.V., 114
Kleineberg, U., 90
Klipp, A., 90
Konishi, A., 99
Kotomin, E.A., 1
Kozuka, H., 172
Kumar, P.M., 122
Kumar, S., 241

Laiho, R., 277
Lam, Y.L., 16
Lange, U., 80
Lee, J.-W., 215
Lee, S., 152
Lenzner, J., 80
Ley, L., 73
Li, H., 62
Liu, Y.-L., 180
Lorenz, M., 80
Luby, S., 90
Lyou, J., 259

Möhwald, H., 229
Mézin, A., 46
Maas, J.H., 234
Maffiotte, C., 22
Majkova, E., 90
Mao, G., 62
Marrone, S.G., 250
Martín, P., 56
Martelli, S., 191
Mathur, P.C., 196
McCaffrey, J.P., 104
McCarthy, J., 146
Mefleh, A., 114
Mehra, R.M., 196
Meissner, D., 241
Melendez-Lira, M., 12
Min, S.-K., 259
Montereali, R.M., 191
Moon, W.S., 86

Neagu, E.R., 283
Neagu, R.M., 283
Nemutudi, R.S., 270

Olesik, J., 114
Olesik, Z., 114
Olivares, J., 56
Outzourhit, A., 40

Park, S.B., 86
Peña, J.L., 12
Pei, Z., 146
Pelli, S., 191
Perrone, M.R., 250
Perry, S.S., 152
Petford-Long, A.K., 94
Protopapa, M.L., 250

Qin, Q., 187
Que, W., 16

Radhakrishnan, G., 131
Ramasami, T., 229
Randall Lee, T., 152
Regragui, M., 40
Righini, G.C., 191
Ringsdorf, H., 241
Rodríguez, A., 56
Rodríguez, T., 56

Šimša, Z., 206
Sajid, B., 46
Sands, D., 6
Sangrador, J., 56
Sastry, M., 122
Schönherr, H., 241
Schmalhorst, J., 90
Shapoval, O., 277
Shiao, M.H., 159
Shieu, F.S., 159

PII: S0040-6090(99)00866-4

Shojiya, M., 99
Shon, Y.-S., 152
Simon Ng, K.Y., 62
Speckman, D.M., 131
Sproule, G.I., 104
Stark, T., 73

Takahashi, Y., 172
Tang, Y., 187
Valentini, A., 250
Vasanelli, L., 250

Wagner, F.X., 6
Wagner, G., 80
Wakabayashi, H., 99
Wang, P., 292
Ward, R.C.C., 94
Wells, M.R., 94
Woo, S.I., 86
Wu, Z.-C., 180

Yang, X., 187
Yoko, T., 172
Yoon, K.-S., 259
Yu, M., 187
Zakhvalinskii, V., 277
Zapata-Navarro, A., 12
Zapata-Torres, M., 12
Zhao, G., 172
Zhou, Y., 16

S-

ELSEVIER

Thin Solid Films 358 (2000) 305–309

thin solid films

Subject Index of Volume 358

Al(111) texture
Oriented wedge-like hillocks on Al-0.5 wt.%Cu/TiN/SiO_2/Si multilayer structure, 292
Al-Cu film
Oriented wedge-like hillocks on Al-0.5 wt.%Cu/TiN/SiO_2/Si multilayer structure, 292
Alkali Halides
Realisation and characterisation of LiF/NaF thin film planar waveguides, 191
Aluminum
FIB micromachined submicron thickness cantilevers for the study of thin film properties, 146
Aluminum nitride
Development of SiN_x and AlN_x passivation layers, 215
Amorphous SiGe films
Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrystalline SiGe films obtained by solid-phase crystallization, 56
Atomic force microscopy
Optical and microstructural properties of sol–gel derived titania/organically modified silane thin films, 16
AFM study of templated growth of cadmium sulfide nanoparticles using pure and mixed arachidate films, 62
Structural characterization and frictional properties of C_{60}-terminated self-assembled monolayers on Au(111), 152
Thin block copolymers films: film formation and corrugation under an AFM tip, 234
Atomistic simulation
Atomistic simulation of $SrTiO_3$ and $BaTiO_3$ (110) surface relaxations, 1
Atomization
Effect of lead acetate concentration on the droplet size in liquid source misted chemical deposition, 86

BaF_2
Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer, 277
Barium
Preparation of ZnF_2 and ZnF_2–BaF_2 thin films by electron cyclotron resonance plasma-enhanced chemical vapor deposition, 99
Block copolymers
Thin block copolymers films: film formation and corrugation under an AFM tip, 234
Brittleness
Unidirectional multiple cracking of coatings described through random sequential placement of rods on a line, 46

Cadmium sulfide
AFM study of templated growth of cadmium sulfide nanoparticles using pure and mixed arachidate films, 62
Cadmium telluride
Low resistance Au contacts to epitaxial n-CdTe formed by excimer laser induced diffusion of In, 6
Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation, 12
Chemical bath deposition
Morphological and compositional study of CBD-ZnSe thin films by microscopy techniques and angle resolved XPS, 22
Chemical vapor deposition
Preparation of ZnF_2 and ZnF_2–BaF_2 thin films by electron cyclotron resonance plasma-enhanced chemical vapor deposition, 99
Coatings
Unidirectional multiple cracking of coatings described through random sequential placement of rods on a line, 46
Low temperature pulsed laser deposition of titanium carbide on bearing steels, 131
Confinement energy
Analysis of the broadening of photoluminescence spectra in porous silicon as a function of growth parameters, 196
Contracts
Low resistance Au contacts to epitaxial n-CdTe formed by excimer laser induced diffusion of In, 6
Copper
Passivation of copper films with magnesium doping using recoil ion implantation, 180
Corrugation
Thin block copolymers films: film formation and corrugation under an AFM tip, 234
Cracks
Unidirectional multiple cracking of coatings described through random sequential placement of rods on a line, 46

Defects
Structural properties of thin $Zn_{0.62}Cu_{0.19}In_{0.19}S$ alloy films grown on Si(111) substrates by pulsed laser deposition, 80
Deposition process
Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation, 12
Synthesis of tantalum pentoxide films by pulsed laser deposition: material characterization and scale-up, 104

PII: S0040-6090(99)000851-2

Pulsed laser deposition of aluminum tris-8-hydroxyquinline thin films, 187
Development of SiN_x and AlN_x passivation layers, 215
Texture development in silver films deposited by ionised magnetron sputter deposition, 264
Dielectric properties
A new method for analysis of isothermal discharging current, 283
Diffusion
Dynamic mechanical properties of ZrO_2/NiCoCrAlY composite coatings, 139
Study of Pt/Ge interaction in a lateral diffusion couple by microbeam Rutherford backscattering spectrometry, 270
Dislocation creep
Oriented wedge-like hillocks on Al-0.5 wt.%Cu/TiN/SiO_2/Si multilayer structure, 292
Droplet
Effect of lead acetate concentration on the droplet size in liquid source misted chemical deposition, 86

Elastic properties
Dynamic mechanical properties of ZrO_2/NiCoCrAlY composite coatings, 139
Electrochemistry
Preparation and photoelectrochemical properties of porous thin films composed of submicron TiO_2 particles, 172
Electron microscopy
Structural properties of thin $Zn_{0.62}Cu_{0.19}In_{0.19}S$ alloy films grown on Si(111) substrates by pulsed laser deposition, 80
Misfit dislocations of epitaxial (110) niobium‖ (11$\bar{2}$0) sapphire interfaces grown by molecular beam epitaxy, 94
Electron temperatures
Internal r.f. plasma parameters correlated with structure and properties of deposited hydrocarbon films, 30
Ellipsometry
Deriving the kinetic parameters for Pt-silicide formation from temperature ramped in situ ellipsometric measurements, 73
Epitaxial relations
Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer, 277

Film density
Influence of film density on residual stress and resistivity for Cu thin films deposited by bias sputtering, 202
Fluorides
Preparation of ZnF_2 and ZnF_2–BaF_2 thin films by electron cyclotron resonance plasma-enhanced chemical vapor deposition, 99
Focused ion beam machining
FIB micromachined submicron thickness cantilevers for the study of thin film properties, 146
Fullerene
Structural characterization and frictional properties of C_{60}-terminated self-assembled monolayers on Au(111), 152

Germanium
Study of Pt/Ge interaction in a lateral diffusion couple by microbeam Rutherford backscattering spectrometry, 270
Gold
Simple method for determining the optical constants of thin metallic films from transmittance measurements, 166
Grazing incidence X-ray reflectivity
Influence of film density on residual stress and resistivity for Cu thin films deposited by bias sputtering, 202
Growth mechanism
Internal r.f. plasma parameters correlated with structure and properties of deposited hydrocarbon films, 30

HfO_2 thin films
HfO_2 films with high laser damage threshold, 250
Hydrocarbons
Internal r.f. plasma parameters correlated with structure and properties of deposited hydrocarbon films, 30

Interfaces
Misfit dislocations of epitaxial (110) niobium‖ (11$\bar{2}$0) sapphire interfaces grown by molecular beam epitaxy, 94
Structural characterization and frictional properties of C_{60}-terminated self-assembled monolayers on Au(111), 152
Interfacial mechanical properties and fracture morphology of a TiN-coated steel wire upon tensile loading, 159
Ion implantation
Passivation of copper films with magnesium doping using recoil ion implantation, 180
Ion plating
Interfacial mechanical properties and fracture morphology of a TiN-coated steel wire upon tensile loading, 159
ITO-glass system
Photoinduced effects in silicon glass coated by In_2O_3–Sn thin layer, 114

Langmuir–Blodgett films
AFM study of templated growth of cadmium sulfide nanoparticles using pure and mixed arachidate films, 62
Laser ablation
Synthesis of tantalum pentoxide films by pulsed laser deposition: material characterization and scale-up, 104
Low temperature pulsed laser deposition of titanium carbide on bearing steels, 131
Pulsed laser deposition of aluminum tris-8-hydroxyquinline thin films, 187
Structural, magnetic and magneto-optical properties of $SrFe_{12-x}Al_xO_{19}$ hexaferrite thin films prepared by laser ablation deposition, 206
Effects of target microstructure on pulsed laser deposited $YBa_2Cu_3O_{7-\delta}$ thin films, 223
Laser damage
HfO_2 films with high laser damage threshold, 250
Laser irradiation
Low resistance Au contacts to epitaxial n-CdTe formed by excimer laser induced diffusion of In, 6
Liquid crystals
Scanning tunneling microscopy investigation of tricycloquinazoline liquid crystals on gold, 241
Liquid source misted chemical deposition
Effect of lead acetate concentration on the droplet size in liquid source misted chemical deposition, 86

Low pressure chemical vapour deposition
Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrystalline SiGe films obtained by solid-phase crystallization, 56
Luminescence
Pulsed laser deposition of aluminum tris-8-hydroxyquinline thin films, 187

Magnesium
Passivation of copper films with magnesium doping using recoil ion implantation, 180
Magnetic properties
Structural, magnetic and magneto-optical properties of $SrFe_{12-x}Al_xO_{19}$ hexaferrite thin films prepared by laser ablation deposition, 206
Micro-cantilever
FIB micromachined submicron thickness cantilevers for the study of thin film properties, 146
Modified melt-textured growth
Effects of target microstructure on pulsed laser deposited $YBa_2Cu_3O_{7-\delta}$ thin films, 223
Molecular beam epitaxy
Misfit dislocations of epitaxial (110) niobium‖ ($11\bar{2}0$) sapphire interfaces grown by molecular beam epitaxy, 94
Monolayers
Scanning tunneling microscopy investigation of tricycloquinazoline liquid crystals on gold, 241
Multilayers
Metal oxide/silicon oxide multilayer with smooth interfaces produced by in situ controlled plasma-enhanced MOCVD, 90

Nanostructures
AFM study of templated growth of cadmium sulfide nanoparticles using pure and mixed arachidate films, 62
Nanocrystalline TiO_2 studied by optical, FTIR and X-ray photoelectron spectroscopy: correlation to presence of surface states, 122
Niobium
Misfit dislocations of epitaxial (110) niobium‖ ($11\bar{2}0$) sapphire interfaces grown by molecular beam epitaxy, 94
Non-linear optics
Photoinduced effects in silicon glass coated by In_2O_3–Sn thin layer, 114

Optical coatings
Preparation and characterization of pyrolytic spray deposited electrochromic tungsten trioxide films, 40
Simple method for determining the optical constants of thin metallic films from transmittance measurements, 166
Optical properties
Preparation and characterization of pyrolytic spray deposited electrochromic tungsten trioxide films, 40
Deriving the kinetic parameters for Pt-silicide formation from temperature ramped in situ ellipsometric measurements, 73
Simple method for determining the optical constants of thin metallic films from transmittance measurements, 166
Realisation and characterisation of LiF/NaF thin film planar waveguides, 191
Organic substances
Pulsed laser deposition of aluminum tris-8-hydroxyquinline thin films, 187
Organically modified silane
Optical and microstructural properties of sol–gel derived titania/organically modified silane thin films, 16
Oriented hillock
Oriented wedge-like hillocks on Al-0.5 wt.%Cu/TiN/SiO_2/Si multilayer structure, 292
Oxidation
Passivation of copper films with magnesium doping using recoil ion implantation, 180
Oxides
Metal oxide/silicon oxide multilayer with smooth interfaces produced by in situ controlled plasma-enhanced MOCVD, 90

PbTe
Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer, 277
Persistent photo-conductivity effect
Structural change and photo-response in porous poly-Si/Si, 259
Phase transition
Dynamic mechanical properties of ZrO_2/NiCoCrAlY composite coatings, 139
Photoacoustic deflection
HfO_2 films with high laser damage threshold, 250
Photoinduced optical effects
Photoinduced effects in silicon glass coated by In_2O_3–Sn thin layer, 114
Photoinduced transformations
Photoinduced effects in silicon glass coated by In_2O_3–Sn thin layer, 114
Photoluminescence
Analysis of the broadening of photoluminescence spectra in porous silicon as a function of growth parameters, 196
Photoreflectance
Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation, 12
Photovoltage
Preparation and photoelectrochemical properties of porous thin films composed of submicron TiO_2 particles, 172
Plasma processing and deposition
Internal r.f. plasma parameters correlated with structure and properties of deposited hydrocarbon films, 30
Metal oxide/silicon oxide multilayer with smooth interfaces produced by in situ controlled plasma-enhanced MOCVD, 90
Dynamic mechanical properties of ZrO_2/NiCoCrAlY composite coatings, 139
Texture development in silver films deposited by ionised magnetron sputter deposition, 264
Platinum
Study of Pt/Ge interaction in a lateral diffusion couple by microbeam Rutherford backscattering spectrometry, 270
Polycrystalline SiGe films
Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrys-

talline SiGe films obtained by solid-phase crystallization, 56
Polycrystalline silicon
Structural change and photo-response in porous poly-Si/Si, 259
Polymers
A new method for analysis of isothermal discharging current, 283
Porous silicon
Analysis of the broadening of photoluminescence spectra in porous silicon as a function of growth parameters, 196
Structural change and photo-response in porous poly-Si/Si, 259
Pulsed laser deposition
Synthesis of tantalum pentoxide films by pulsed laser deposition: material characterization and scale-up, 104

Quantum confinement
Structural change and photo-response in porous poly-Si/Si, 259
Quantum effects
Analysis of the broadening of photoluminescence spectra in porous silicon as a function of growth parameters, 196

Raman
Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation, 12
Raman spectroscopy
Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrystalline SiGe films obtained by solid-phase crystallization, 56
Reaction kinetics
Deriving the kinetic parameters for Pt-silicide formation from temperature ramped in situ ellipsometric measurements, 73
Residual stress
Influence of film density on residual stress and resistivity for Cu thin films deposited by bias sputtering, 202
Resistivity
Influence of film density on residual stress and resistivity for Cu thin films deposited by bias sputtering, 202
Rutherford backscattering spectrometry
Study of Pt/Ge interaction in a lateral diffusion couple by microbeam Rutherford backscattering spectrometry, 270

Scanning tunnelling microscopy
Scanning tunneling microscopy investigation of tricycloquinazoline liquid crystals on gold, 241
Schottky barrier
Low resistance Au contacts to epitaxial n-CdTe formed by excimer laser induced diffusion of In, 6
Selenides
Morphological and compositional study of CBD-ZnSe thin films by microscopy techniques and angle resolved XPS, 22
Self assembled monolayers
Scanning tunneling microscopy investigation of tricycloquinazoline liquid crystals on gold, 241
Semiconductors
Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation, 12
Morphological and compositional study of CBD-ZnSe thin films by microscopy techniques and angle resolved XPS, 22
Si(001)
Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer, 277
Silicides
Deriving the kinetic parameters for Pt-silicide formation from temperature ramped in situ ellipsometric measurements, 73
Silicon
FIB micromachined submicron thickness cantilevers for the study of thin film properties, 146
Silicon nitride
Development of SiN_x and AlN_x passivation layers, 215
Size measurement
Effect of lead acetate concentration on the droplet size in liquid source misted chemical deposition, 86
Sol–gel technique
Optical and microstructural properties of sol–gel derived titania/organically modified silane thin films, 16
Solid-phase crystallization
Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrystalline SiGe films obtained by solid-phase crystallization, 56
Solid-state sintering
Effects of target microstructure on pulsed laser deposited $YBa_2Cu_3O_{7-\delta}$ thin films, 223
Spray pyrolysis
Preparation and characterization of pyrolytic spray deposited electrochromic tungsten trioxide films, 40
Sputtering
Texture development in silver films deposited by ionised magnetron sputter deposition, 264
Statistics
Unidirectional multiple cracking of coatings described through random sequential placement of rods on a line, 46
Steel
Interfacial mechanical properties and fracture morphology of a TiN-coated steel wire upon tensile loading, 159
Strontium hexaferrites
Structural, magnetic and magneto-optical properties of $SrFe_{12-x}Al_xO_{19}$ hexaferrite thin films prepared by laser ablation deposition, 206
Structural properties
Realisation and characterisation of LiF/NaF thin film planar waveguides, 191
Development of SiN_x and AlN_x passivation layers, 215
Sulfides
Structural properties of thin $Zn_{0.62}Cu_{0.19}In_{0.19}S$ alloy films grown on Si(111) substrates by pulsed laser deposition, 80
Surfaces
Thin block copolymers films: film formation and corrugation under an AFM tip, 234
Surface and interface states
Atomistic simulation of $SrTiO_3$ and $BaTiO_3$ (110) surface relaxations, 1
Nanocrystalline TiO_2 studied by optical, FTIR and X-ray photoelectron spectroscopy: correlation to presence of surface states, 122
Surface composition
Nanocrystalline TiO_2 studied by optical, FTIR and X-ray photoelectron spectroscopy: correlation to presence of surface states, 122

Surface morphology
Effects of target microstructure on pulsed laser deposited $YBa_2Cu_3O_{7-\delta}$ thin films, 223
Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer, 277
Surface structures
Thin block copolymers films: film formation and corrugation under an AFM tip, 234

Ta_2O_5
Synthesis of tantalum pentoxide films by pulsed laser deposition: material characterization and scale-up, 104
Thin films
Structural properties of thin $Zn_{0.62}Cu_{0.19}In_{0.19}S$ alloy films grown on Si(111) substrates by pulsed laser deposition, 80
Effect of lead acetate concentration on the droplet size in liquid source misted chemical deposition, 86
Thin film transistors
Raman spectroscopy study of amorphous SiGe films deposited by low pressure chemical vapor deposition and polycrystalline SiGe films obtained by solid-phase crystallization, 56
Titanium carbide
Low temperature pulsed laser deposition of titanium carbide on bearing steels, 131
Titanium dioxide
Preparation and photoelectrochemical properties of porous thin films composed of submicron TiO_2 particles, 172
Titanium nitride
Interfacial mechanical properties and fracture morphology of a TiN-coated steel wire upon tensile loading, 159
Titanium oxide
Nanocrystalline TiO_2 studied by optical, FTIR and X-ray photoelectron spectroscopy: correlation to presence of surface states, 122
Tribology
Low temperature pulsed laser deposition of titanium carbide on bearing steels, 131
Structural characterization and frictional properties of C_{60}-terminated self-assembled monolayers on Au(111), 152
Tungsten oxide
Simple method for determining the optical constants of thin metallic films from transmittance measurements, 166
Twins
Growth of (111)-oriented PbTe films on Si(001) using a BaF_2 buffer, 277

UV–visible spectroscopy
Optical and microstructural properties of sol–gel derived titania/organically modified silane thin films, 16

X-ray diffraction
Structural transition from CdTe to $CdIn_2Te_4$ in films grown by close paced vapor transport combined with free evaporation, 12
Realisation and characterisation of LiF/NaF thin film planar waveguides, 191
Texture development in silver films deposited by ionised magnetron sputter deposition, 264
X-ray photoelectron spectroscopy (XPS)
Morphological and compositional study of CBD-ZnSe thin films by microscopy techniques and angle resolved XPS, 22
Preparation and characterization of pyrolytic spray deposited electrochromic tungsten trioxide films, 40

Zinc
Preparation of ZnF_2 and ZnF_2–BaF_2 thin films by electron cyclotron resonance plasma-enhanced chemical vapor deposition, 99